

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	HIJZEN	Examiner:	Prenty, Mark V.
Serial No.:	10/538,217	Group Art Unit:	2822
Filed:	June 9, 2005	Docket No.:	NL021418 US
Title:	METHOD OF MANUFACTURE OF A TRENCH-GATE SEMICONDUCTOR DEVICE		

AMENDMENT AND RESPONSE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Customer No. 65913

Dear Sir:

In acknowledgement of the non-final Office Action dated March 21, 2008, please consider the following amendments and remarks.

A complete listing of the Claims begins on page 2 of this paper.

Remarks/Arguments follow on page 5.

Authorization is given to charge/credit Deposit Account 50-0996 (NXPS.239PA)
all requisite fees/overages to enter this paper.